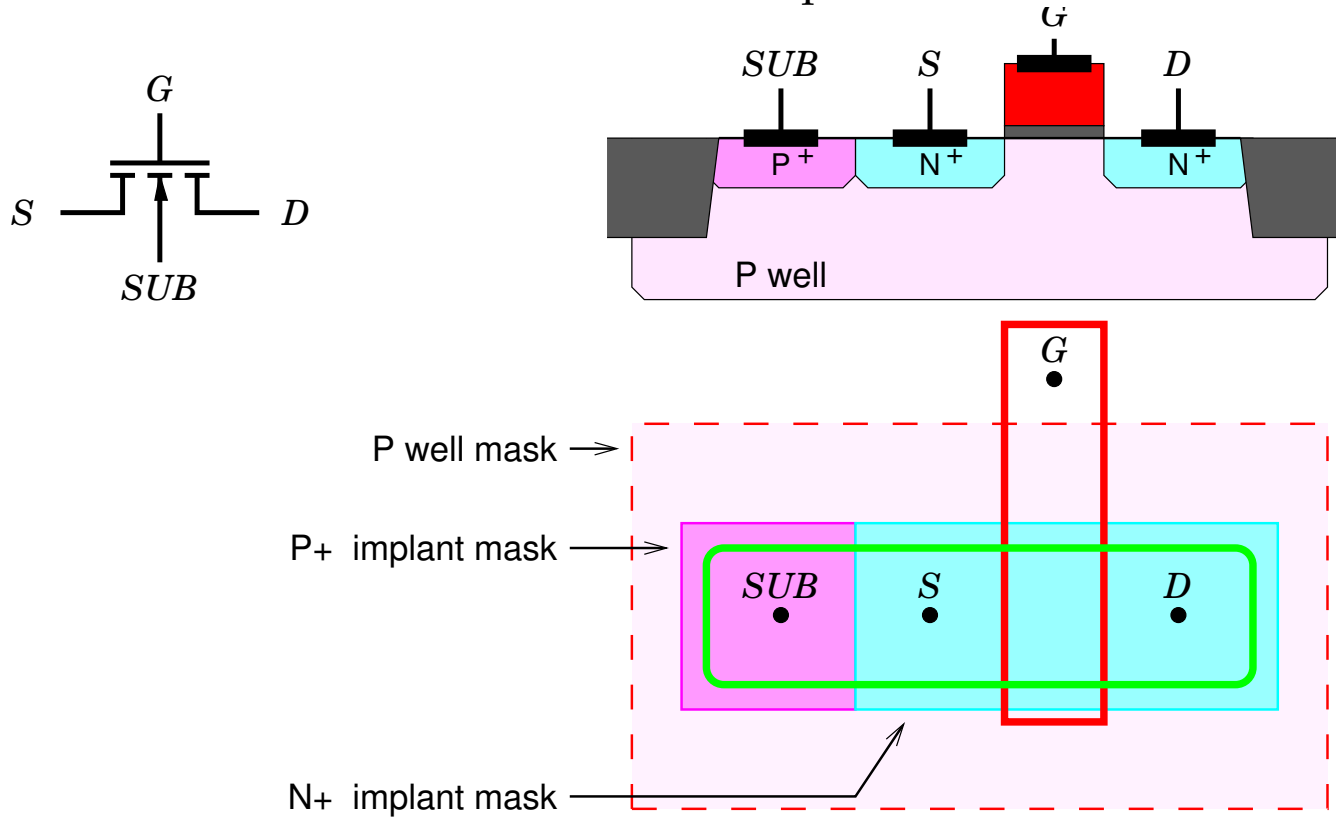


# CMOS

## NMOS Transistor – with top substrate connection



# CMOS

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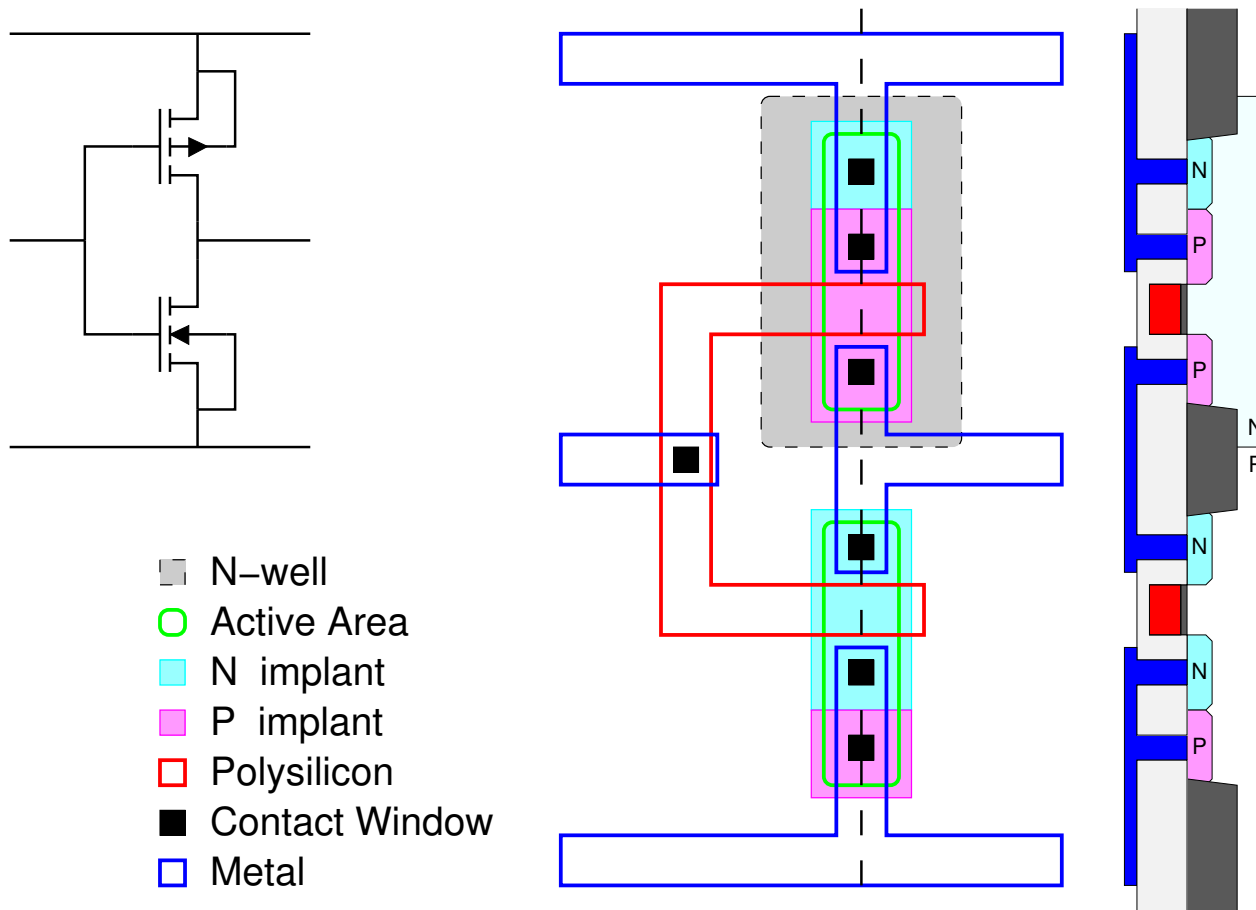
## NMOS Transistor – with top substrate connection

Where it is not suitable for substrate connections to be shared, a more complex process is used.

- Five masks must be used to define the transistor:
  - P Well
  - Active Area
  - Polysilicon
  - N+ implant
  - P+ implant
- P Well, for isolation.
- Top *substrate* connection.
- P+/N+ implants produce good *ohmic* contacts.

# CMOS

## CMOS Inverter



# CMOS

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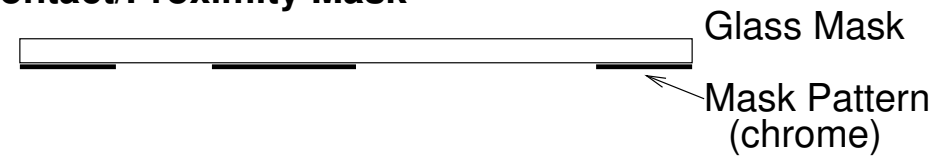
## CMOS Inverter

- The process described here is an *N Well process* since it has only an N Well. P Well and Twin Tub processes also exist.
- Note that the P-N junction between chip substrate and N Well will remain reverse biased.  
Thus the transistors remain isolated.
- N implant defines NMOS source/drain and PMOS substrate contact.
- P implant defines PMOS source/drain and NMOS substrate contact.

# Processing – Photolithography

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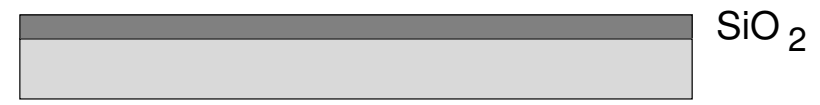
## Contact/Proximity Mask



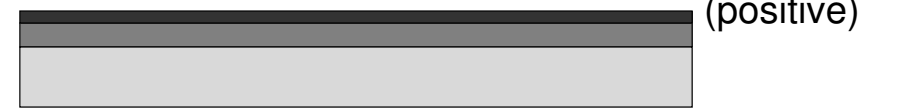
## Silicon Wafer



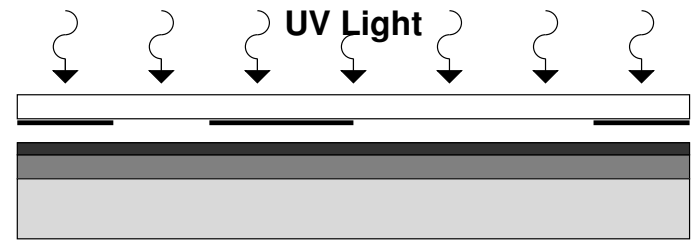
## Oxide Growth



## Photoresist Deposition



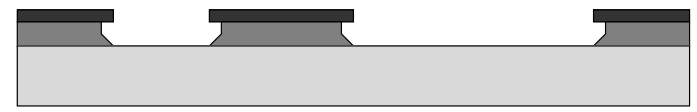
## Photoresist Exposure



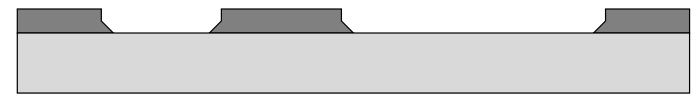
## Photoresist Development



## Oxide Etch



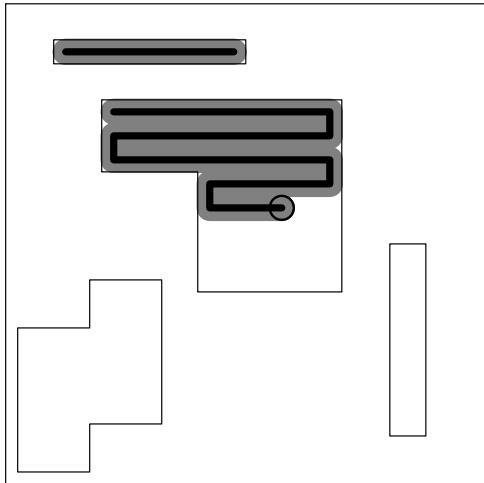
## Photoresist Strip



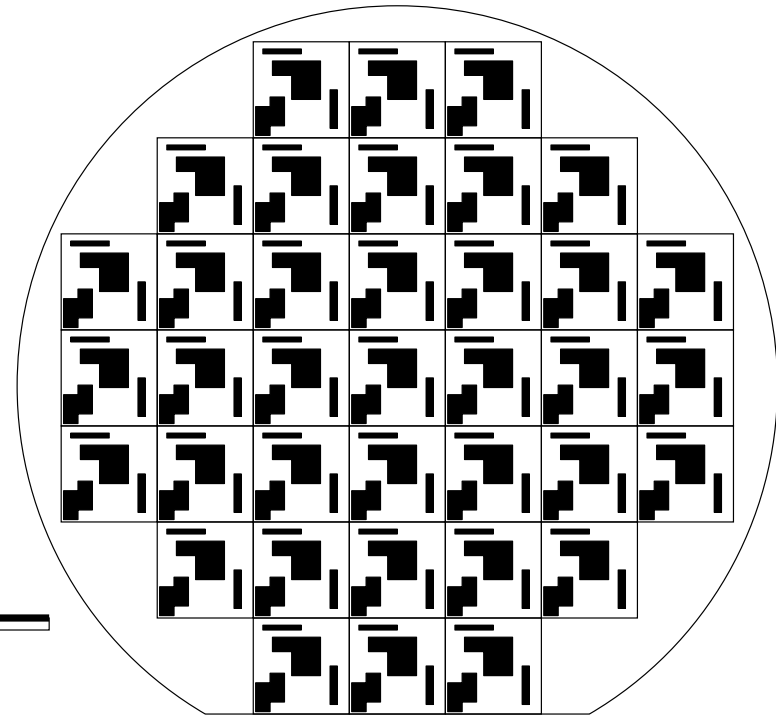
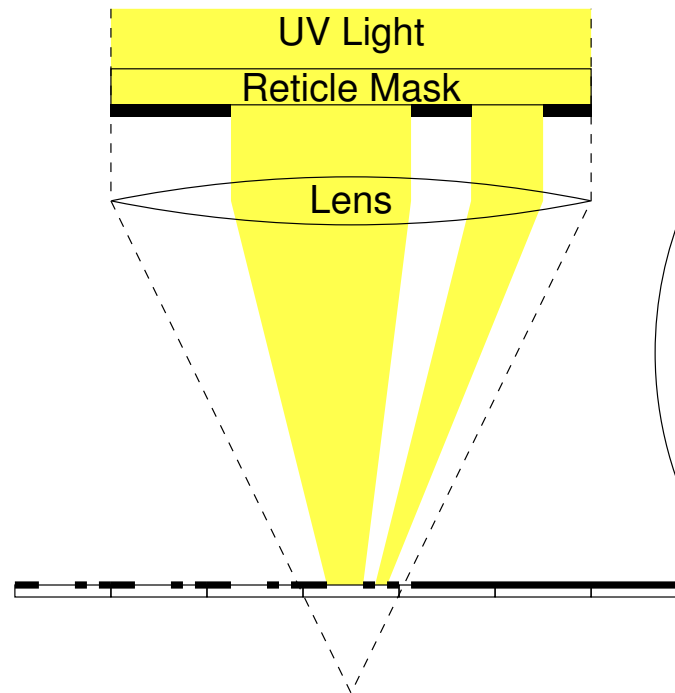
# Processing – Mask Making

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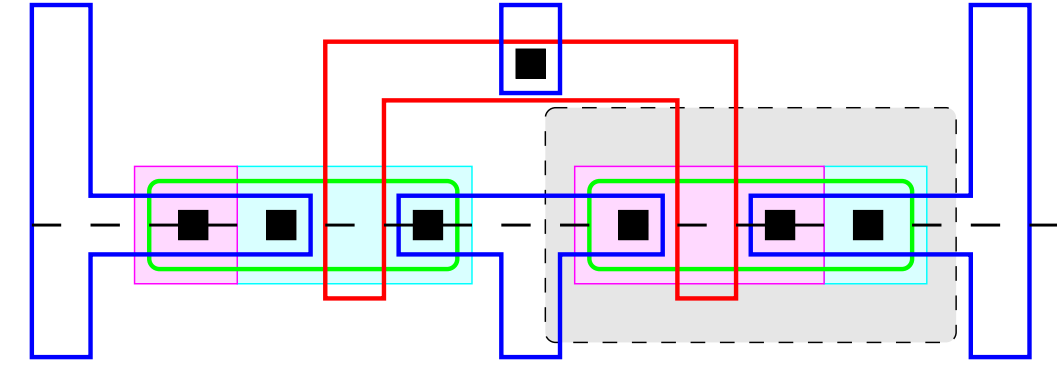
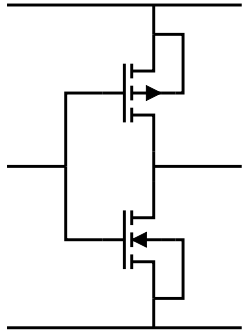
Reticle written by scanning electron beam



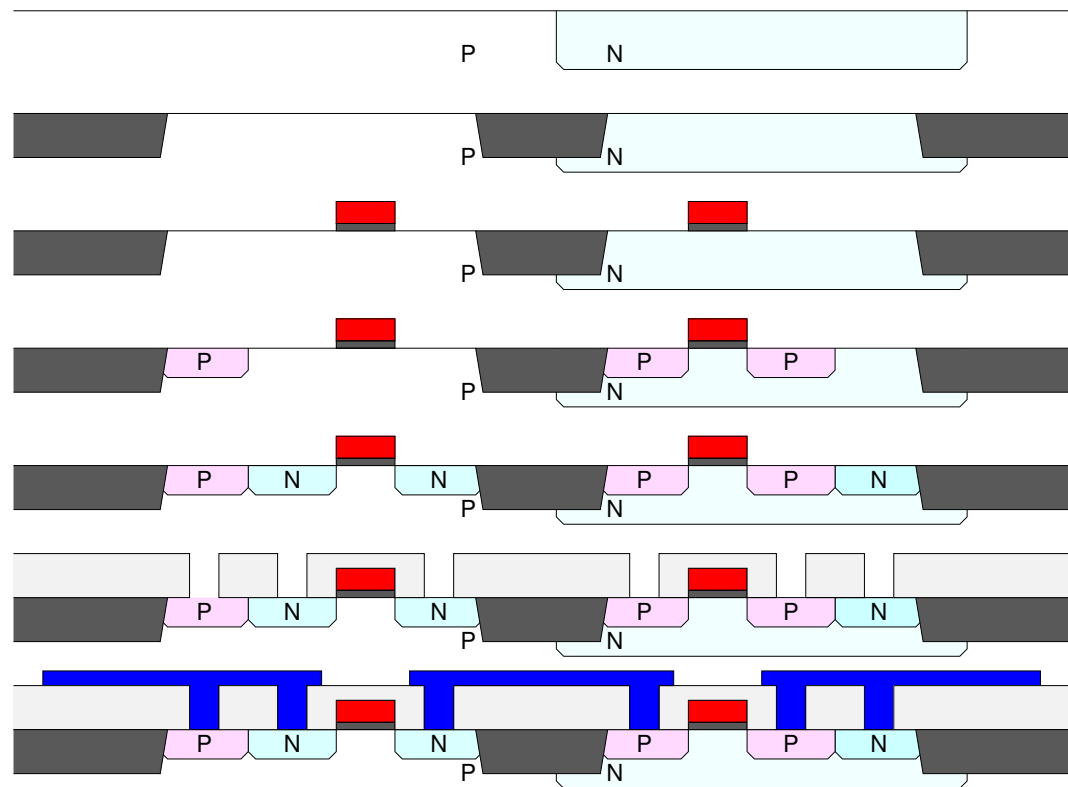
Pattern reproduced on wafer (or contact/proximity mask) by step and repeat with optical reduction



- Optical reduction allows narrower line widths.



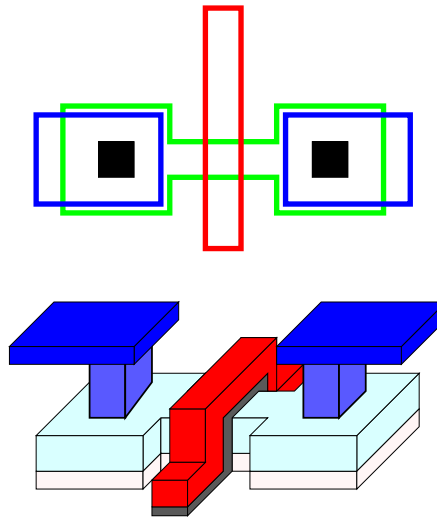
- N-well
- Active Area  
defines Thick Oxide
- Polysilicon  
defines Thin Oxide
- P implant  
aligned to AA and Poly
- N implant  
aligned to AA and Poly
- Contact Window
- Metal



# CMOS - Short Gate Techniques

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## Fin FET



- With the aid of trenches we raise the active area above the bulk silicon.
- We can then wrap the gate around the channel.
- Avoids an effect where a channel is created in a region which is closer to the drain than the gate.